



mag e

1762

PATENT 1731
83373.0002

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Franklin W. Dabby, et al.

Serial No: 09/894,447

Filed: June 28, 2001

For: PARTICLE DEPOSITION SYSTEM
AND METHOD

Art Unit: 1762

Confirmation No.: 5193

Examiner: Not Assigned

I hereby certify that this correspondence is
being deposited with the United States Postal
Service with sufficient postage as first class
mail in an envelope addressed to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
September 22, 2003
Date of Deposit
Ying Chen, Reg. No. 50,193
Name
Signature 
Date 9/22/03

THIRD STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The above-referenced application was filed on June 28, 2001 and a second status request was filed on March 5, 2003. A status reply was received from the Patent Office indicating the application would be examined by August 19, 2003. To date, no further papers have been received in this case.

Please send the undersigned a Status Report on this application.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By: 

Ying Chen
Registration No. 50,193
Attorney for Applicant(s)

Date: September 22, 2003

500 South Grand Avenue, Suite 1900
Los Angeles, California 90071
Phone: 213-337-6700
Fax: 213-337-6701